

Docket No. 206276US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Toshiaki WATANABE

FILING DATE: Herewith

FOR: EXPOSURE CONTROL APPARATUS AND METHOD THEREOF



LIST OF INVENTOR'S NAME AND ADDRESS

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Listed below is the name and address of the inventor for the above-identified patent application.

Toshiaki WATANABE

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A declaration containing all the necessary information will be submitted at a later date.

Respectfully Submitted,

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